



V085413597
EL979951755

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application Serial No.08/846,671
Filing DateApril 30, 1997
InventorKei-Yu Ko
AssigneeMicron Technology, Inc.
Group Art Unit1763
ExaminerGeorge A. Goudreau
Attorney Docket No.MI22-2041
Title: Undoped Silicon Dioxide as Etch Stop for Selective Etch of Doped Silicon
Dioxide

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

References -- See Attached Form PTO-1449

The attached form PTO-1449 is submitted in compliance with
37 CFR §1.56. Copies of the cited art are included. No admission is made
regarding whether all the submitted references are prior art.

Respectfully submitted,

Dated: _____

6-6-03

By: _____

Mark S. Matkin
Reg. No. 32,268

Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-2041		SERIAL NO. 08/846,671		
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)				APPLICANT: Kei-Yu Ko				
				FILING DATE April 30, 1997		GROUP 1763		
U.S. PATENT DOCUMENTS								
*Examiner's Initials		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
	AA	5,430,328	07/04/95	Hsue				
	AB	6,065,481	05/23/00	Fayfield et al.				
	AC	6,362,109	03/26/02	Kim et al.				
	AD	6,372,605 B1	04/16/02	Kuehne et al.				
	AE							
	AF							
	AG							
	AH							
FOREIGN PATENT DOCUMENTS								
		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
	AI	6146/91	27.08.92	Japan (Nakano)			X	
	AJ	6-69166	11.03.94	Japan (Tokuhiko)			X	
	AK	8-181121	12.07.96	Japan (Fujita)			X	
	AL	8-250449	27.09.96	Japan (Tetsuo)			X	
OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)								
	AM							
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.								

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The stamp of the U.S. Patent and Trademark Office acknowledges receipt of the following papers relating to the Patent application of **Keiichi No**, Serial No. 08/846,671, filed April 30, 1997, entitled "Undoped Silicon Dioxide as Etch Stop for Selective Etch of Doped Silicon Dioxide".

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